

04-11-05

RCE/2811/
ZJW

Practitioner's Docket No.: 800_134

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Yuji HORI, Osamu ODA, Mitsuhiro TANAKA, Bruno DAUDIN and
Eva MONROY

Appl. No.: 10/813,565

Group Art Unit: 2811

Filed: March 30, 2004

Examiner: Cuong Quang Nguyen

Confirmation No.: 4125

For: SUBSTRATE FOR SEMICONDUCTOR LIGHT-EMITTING ELEMENT,
SEMICONDUCTOR LIGHT-EMITTING ELEMENT AND SEMICONDUCTOR
LIGHT-EMITTING ELEMENT FABRICATION METHOD

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 8, 2005 under "EXPRESS MAIL" mailing label number EV 40699 2565 US.

Janet M. Stevens
Janet M. Stevens

REQUEST FOR CONTINUED EXAMINATION
(37 CFR §1.114)

1. Applicant hereby requests continued examination, in accordance with 37 CFR §1.114, for the above identified application.
2. This request is being submitted:
 - i. Prior to abandonment of the application
 - ii. Payment of the issue fee
 - Prior to payment of issue fee
 - Issue fee has been paid but a petition under §1.313 was filed _____
(copy attached).
 - iii. Prior to a decision on appeal to the Board of Patent Appeals & Interferences
 - A notice is being separately sent to the Board of Patent Appeals & Interferences that this Request for Continued Examination is being filed.
 - iv. Appeal to the U.S. Court of Appeals of the Federal Circuit under 35 U.S.C. 145 or
 - Commencement of a civil action under 35 U.S.C. 146
 - Prior to the filing of such appeal or commencement of civil action
 - Such appeal or commencement of civil action has been terminated.

3. Please Enter and Consider the following *Previously Submitted Documents*:

- [] Amendment filed _____.
[] Brief on Appeal filed _____.
[] Other:

4. Enclosed herewith is/are:

- [X] An Information Disclosure Statement and Form PTO-1449
[] An Amendment
[] New arguments
[] New evidence in support of patentability
[] Other:

5. The filing fee has been calculated as shown below:

RCE Filing Fee (37 CFR §1.17(e))						\$ 790.00
Claims	Claims Remaining After Amendment		Highest Number Previously Paid	No. of Extra Claims Present		
Total Claims	13	Minus	20	0	\$ 50.00	
Independent Claims	2	Minus	3	0	\$ 200.00	
Multiple Dependent Claim(s) (if applicable)						\$ 360.00
<u>Extension of Term</u>						
a.	[X] Applicant believes that no extension of term is required. However, this conditional petition is being made to provide for the possibility that applicant has inadvertently overlooked the need for a petition and fee for extension of time.					
b.	[] Applicant petitions for an extension of time, the fees for which are set out in 37 CFR §1.17(a)(1)-(4), for the total number of months checked below: [] One Month (37 CFR 1.17(a)(1)) \$ 120.00 [] Two Months (37 CFR 1.17(a)(2)) \$ 450.00 [] Three Months (37 CFR 1.17(a)(3)) \$1,020.00					
If an additional extension of time is required, please consider this a petition therefor.						
[] An extension for _____ months has already been secured, and the fee paid therefor of \$_____ is deducted from the total fee due for the total months of extension now requested.						
TOTAL OF ABOVE CALCULATIONS =						\$ 790.00
[] Applicant claims small entity status. See 37 CFR §1.27.						
TOTAL FEES DUE =						\$ 790.00

6. Payment of Fees

A check in the amount of \$790.00 is enclosed.

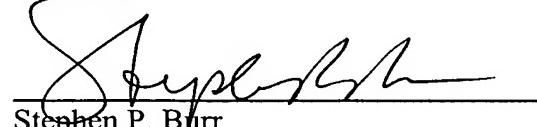
Charge Deposit Account 50-1446 in the amount of \$.

7. Authorization to Charge Additional Fees or Credit Overpayment

The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-1446 (a duplicate copy of this sheet is enclosed):

Any additional fees required under 37 CFR §1.17(e), §1.16(b)-(d) and/or §1.17(a)(1)-(4).

Respectfully submitted,



Stephen P. Burr
Reg. No. 32,970

SPB:jms

BURR & BROWN
P.O. Box 7068
Syracuse, NY 13261-7068

Customer No.: 025191
Telephone: (315) 233-8300
Facsimile: (315) 233-8320



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PATENT

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Janet M. Stevens

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Required copies of the references listed on Form PTO-1449 are attached.

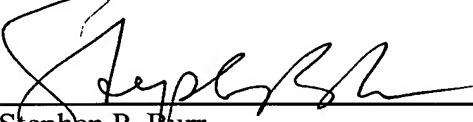
Also enclosed is a copy of a European Search Report from a corresponding European patent application bearing a mailing date of November 7, 2003, and the U.S. PTO is directed thereto for a concise statement of possible relevance of the references cited therein.

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this

application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-1446.

Respectfully submitted,



Stephen P. Burr
Reg. No. 32,970

SPB:jms

BURR & BROWN
P.O. Box 7068
Syracuse, NY 13261-7068

Customer No.: 025191
Telephone: (315) 233-8300
Facsimile: (315) 233-8320

APR 08 2005

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

				<i>Complete if Known</i>	
Application Number		10/813,565			
Filing Date		March 30, 2004			
First Named Inventor		Yuji Hori			
Art Unit		2811			
Examiner Name		Cuong Quang Nguyen			
Confirmation No.		4125			
Sheet	1	of	2	Attorney Docket No.	800_134

U.S. PATENT DOCUMENTS

Exam. Initial		Document Number	Date	Name	Our Docket No.	Class	Sub Class	Filing Date
	<i>AA</i>	2002/0053679 A1	05/09/2002	Nikolaev et al.				
	<i>AB</i>	2002/0136932 A1	09/26/2002	Yoshida				
	<i>AC</i>	5,488,233	01/30/1996	Ishikawa et al.				
	<i>AD</i>	5,740,192	04/14/1998	Hatano et al.				

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
	<i>AE</i>	1 211 737 A2	06/05/2002	EP				
	<i>AF</i>	00/63961	10/26/2000	WO				

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages etc.)

	<i>AG</i>	SHIBATA T ET AL: "Characterization of high-quality epitaxial AlN films grown by MOVPE", GAN AND RELATED ALLOYS - 2001. Symposium (Materials Research Society Symposium Proceedings Vol. 693), GAN AND RELATED ALLOYS - 2001, BOSTON, MA, USA, 26-30 JAN. 2001, pages 541-544, XP001168620, 2002, Warrendale, PA, USA, Mater. Res. Soc., USA *abstract*
	<i>AH</i>	SAXLER A ET AL: "High quality aluminum nitride epitaxial layers grown on sapphire substrates", APPLIED PHYSICS LETTERS, 17 JAN. 1994, USA, vol. 64, no. 3, pages 339-341, XP002256572, ISSN: 0003-6951 *page 340*
	<i>AI</i>	OHBA Y ET AL: "Growth of high-quality AlN and AlN/GaN/AlN heterostructure on sapphire substrate" JAPANESE JOURNAL OF APPLIED PHYSICS, PART 2 (LETTERS), 15 AUG. 1996, PUBLICATION OFFICE JAPANESE JOURNAL APPL. PHYS. JAPAN, vol. 35, no. 8B, pages L1013-L1015, XP002256573, ISSN: 0021-4922 *L1013-L1014*
	<i>AJ</i>	KAUFMANN U ET AL: "Hole conductivity and compensation in epitaxial GaN:Mg layers" PHYSICAL REVIEW B (CONDENSED MATTER), 15 OCT. 2000, APS THROUGH AIP, USA, vol. 62, no. 16, pages 10867-10872, XP002256574, ISSN: 0163-1829 *page 10867*
	<i>AK</i>	SANTIC B ET AL: "Current transport mechanism and I-V characteristics of titanium and indium contacts to p-type GaN" MATERIALS SCIENCE & ENGINEERING B (SOLID-STATE MATERIALS FOR ADVANCED TECHNOLOGY), 30 MAY 2002, ELSEVIER, SWITZERLAND, vol. B93, pages 202-206, XP002255818, ISSN: 0921-5107, *the whole document*

APR 08 2005

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(use as many sheets as necessary)

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Application Number	10/813,565
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First Named Inventor	Yuji Hori
Art Unit	2811
Examiner Name	Cuong Quang Nguyen
Confirmation No.	4125

Sheet 2 of 2 Attorney Docket No. 800_134

	AK	BHARGAVA R N: "The role of impurity in doped nanocrystals" 1996 INTERNATIONAL CONFERENCE ON LUMINESCENCE AND OPTICAL SPECTROSCOPY OF CONDENSED MATTER, PRAGUE, CZECH REPUBLIC, 18-23 AUG. 1996, vol. 72-74, pages 46-48, XP002255817, Journal of Luminescence, June 1997, Elsevier, Netherlands, ISSN: 0022-2313 *the whole document*
	AL	ZHANG J ET AL: "INGAN SELF-ASSEMBLED QUANTUM DOTS GROWN BY METALORGANIC CHEMICAL-VAPOR DEPOSITION WITH INDIUM AS THE ANTISURFACTANT" APPLIED PHYSICS LETTERS, AMERICAN INSTITUTE OF PHYSICS, NEW YORK, US, vol. 80, no. 3, 21 January 2002 (2002-01-21), pages 485-487, XP001093504, ISSN: 0003-6951 *page 485*

Examiner: _____ Date Considered: _____

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

***In accordance with the Notice dated July 11, 2003 on the PTO website, we are not enclosing copies of any of the above U.S. references.**